

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Ghaemmaghami, et al.

Serial No.: 09/497,320

Filed: February 3, 2000

APR 2 5 200

Date: April 21, 2000

Group Art Unit: 2815

Examiner: Unassigned

METHOD AND SYSTEM FOR PROVIDING HALO IMPLANT TO A For:

SEMICONDUCTOR DEVICE WITH MINIMAL IMPACT TO THE

JUNCTION CAPACITANCE

**Assistant Commissioner for Patents** Washington, D.C. 20231

## REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.

This filing receipt did not include the Continuing Data Information as Claimed by Applicant. This application claims benefit of U.S. Provisional Application No. 60/168,155 filed on November 29, 1999. This information should be added.

The correction is not due to any error by applicant and no fee is due.

If any unresolved issues remain, please contact Applicant's attorney at the telephone number indicated below.

Respectfully submitted,

Stephen G. Sullivan

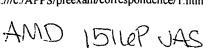
Attorney for Applicant(s)

Reg. No. 38,329 (650) 493-4540

TECHNOLOGY CENTER 2800







## **FILING RECEIPT**

APR 1 3 2000

\*OC000000005032038\*

## UNITED STATES DEPARTMENT OF COMMERCE Patent and Trademark Office

Address: ASSISTANT SECRETARY AND

COMMISSIONER OF PATENT AND TRADEMARKS

Washington, D.C. 20231

	APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
•	09/497,320	02/03/2000	2815	690	E0545/1516P	4	14	2

Joseph A. Sawyer Jr. Sawyer & Associates PO BOX 51418 Palo Alto, CA 94303

Date Mailed: 04/05/2000

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Ahmad Ghaemmaghami, Gilroy, CA IRAN, ISLAMIC REPUBLIC OF, Zoran Krivokapic, Santa Clara, CA SLOVENIA; Brian Swanson, San Jose, CA;

claims benefit of US Prvsn'l Appln 60/168,155 filed 11-29-99 Continuing Data as Claimed by Applicant

**Foreign Applications** 

If Required, Foreign Filing License Granted 04/05/2000

RECEIVED

MAY 25 2000

Title

TECHNOLOGY CENTER 2800

Method and system for providing halo implant to a semiconductor device with minimal impact to the junction capacitance

**Preliminary Class** 

257

Data entry by : RORIE, DEANNA

Team: OIPE

Date: 04/05/2000







Bib Data Sheet



UNITED STATES DEPARTMENT OF COMMERCE
Patent and Trademark Office

Address: COMMISSIONER OF PATENTS AND TRADEMARKS Washington, D.C. 20231

SERIAL NUMBER 09/497,320	02/03/2000 RULE _	<b>CLASS</b> 257		GROUP ART UNIT 2815		JNIT	ATTORNEY DOCKET NO. E0545/1516P				
APPLICANTS  Ahmad Ghaemmaghami, Gilroy, CA; Zoran Krivokapic, Santa Clara, CA; Brian Swanson, San Jose, CA;  *** CONTINUING DATA *******************************  THIS APPLN CLAIMS BENEFIT OF 60/168,155 11/29/1999  *** FOREIGN APPLICATIONS ************************************											
IF REQUIRED, FOREIGN FILING LICENSE ** GRANTED ** 04/05/2000											
Foreign Priority claimed  35 USC 119 (a-d) conditions met  Verified and Acknowledged  Ex	Allowance	fter fnitials	1		IEETS AWING 4	TOTA CLAIM 14		INDEPENDENT CLAIMS 2			
ADDRESS											
Joseph A. Sawyer Jr. Sawyer & Associates PO BOX 51418 Palo Alto ,CA 94303											
TITLE  Method and system for providing halo implant to a semiconductor device with minimal impact to the junction appacitance											
FILING FEE RECEIVED No to charge/credit DEPOSIT ACCOUNT No for following:					All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time)  1.18 Fees (Issue)  Other  Credit						